

LaNumber	Hits	Search Text	DB	Time stamp
-	4	((("5304253") or ("5882416") or ("6332925") or ("6263590")).PN.	USPAT;	2003/12/30 13:15
-	2	"62294180"	US-PGPUB JPO;	2003/06/12 09:55
-	1	("6263590").PN.	DERWENT USPAT;	2003/12/30 13:19
-	4	("5621982" "6107198" "6139642" "6165272").PN.	US-PGPUB USPAT	2003/12/30 13:15
-	8	("4168741" "5015503" "5250323" "5261963" "5536319" "5584963" "5788747" "5888579").PN.	USPAT	2003/12/30 13:17
-	31	5250323.URPN.	USPAT	2003/12/30 13:18
-	20	(exhaust same ((trap filter) with bypass) same (clean\$3 with gas)) and (wafer substrate semiconductor)	USPAT; US-PGPUB	2003/12/30 13:20
-	1	("6107198").PN.	USPAT;	2004/01/05 13:04
-	8	("4168741" "5015503" "5250323" "5261963" "5536319" "5584963" "5788747" "5888579").PN.	US-PGPUB USPAT	2004/01/05 13:04
-	13	5888579.URPN.	USPAT	2004/01/05 13:10
-	2	(exhaust same ((trap filter) with bypass) same (clean\$3 with gas)) and (wafer substrate semiconductor)	EPO; JPO; DERWENT	2004/01/05 14:13
-	1	4906257.pn.	EPO; JPO; DERWENT	2004/01/05 14:36
-	0	314299.URPN.	USPAT	2004/01/05 14:16
-	1	("6149729").PN.	USPAT; US-PGPUB	2004/01/05 14:36
-	55	okase-wataru.in. matsushima-noriaki.in. tsukada-akihiho.in. shimomura-kouji.in.	USPAT;	2004/10/05 17:48
-	61	okase-wataru.in. matsushima-noriaki.in. tsukada-akihiho.in. shimomura-kouji.in.	US-PGPUB USPAT;	2004/10/05 14:42
-	4	(okase-wataru.in. matsushima-noriaki.in. tsukada-akihiho.in. shimomura-kouji.in.) and bypass	US-PGPUB USPAT;	2004/10/05 14:42
-	4	(okase-wataru.in. matsushima-noriaki.in. tsukada-akihiho.in. shimomura-kouji.in.) and bypass\$3	USPAT; US-PGPUB	2004/10/05 14:56
-	522	((204/298.07) or (204/298.33)).CCLS.	USPAT;	2004/10/05 14:56
-	19	((204/298.07) or (204/298.33)).CCLS.) and bypass\$3	US-PGPUB USPAT;	2004/10/05 15:19
-	396	118/715-733.ccls. and bypass\$3	US-PGPUB USPAT;	2004/10/05 15:20
-	179	118/715-733.ccls. and (bypass\$3 with (exhaust\$3 evacuat\$3 vacuum exit\$3))	USPAT; US-PGPUB	2004/10/05 15:20
-	191	(118/715-733.ccls. 156/345\$.ccls.) and (bypass\$3 with (exhaust\$3 evacuat\$3 vacuum exit\$3))	USPAT; US-PGPUB	2004/10/05 17:00
-	5	5611863.URPN.	USPAT	2004/10/05 15:35
-	4	("4816113" "4971667" "5368685" "5512102").PN.	USPAT	2004/10/05 15:36
-	64	(c23c016\$.ipc. c23f021\$.ipc.) and (bypass\$3 with (exhaust\$3 evacuat\$3 vacuum exit\$3))	EPO; JPO; DERWENT	2004/10/06 15:33
-	10	(wafer substrate semiconductor workpiece) and (trap\$3 with bypass\$3 with (exhaust\$3 evacuat\$3 vacuum exit\$3))	EPO; JPO; DERWENT	2004/10/05 17:21
-	4	"2001007030"	EPO; JPO; DERWENT	2004/10/05 17:21
-	2	"11001773"	EPO; JPO; DERWENT	2004/10/05 17:27
-	264	IWATa-TERUO.in. FUJIKAWA-YUICHIRO.in. HORIUCHI-TAKASHI.in. HAYASHI-KAZUICHI.in.	EPO; JPO; DERWENT	2004/10/05 17:48

